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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Albert E. CHU; John L.

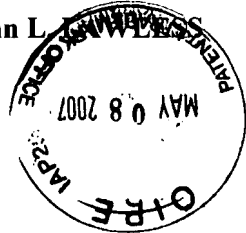
Patent No. 7,031,508

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Application No. 10/606,010

Filed: June 24, 2003

For: **REFLECTOMETRY SYSTEM WITH
COMPENSATION FOR SPECIMEN
HOLDER TOPOGRAPHY AND WITH
LOCK REJECTION OF SYSTEM
NOISE**



Docket No.: 67451-5021 / 02-US

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